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Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L2	1606	stor\$3 and library and layout and pattern and diagram and mask	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2004/06/21 08:29
L3	5497246	stor\$3 WITh4 library with3 layout with3 pattern with3 diagram with3 mask	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2004/06/21 08:34
L4	1606	2 and 3	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2004/06/21 08:33
L6	968	semiconductor and I4	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2004/06/21 08:40
L7	330	mask ADJ3 pattern and I6	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2004/06/21 08:41

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Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	740	(716/19).CCLS.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2004/06/21 11:41
L2	737	(716/8).CCLS.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2004/06/21 11:41
L3	25	1 and 2	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2004/06/21 11:42
L4	1452	1 or 2	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2004/06/21 11:42
L5	76	macro\$4 and mask and I4	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2004/06/21 11:43
L6	71	macro\$4 and mask and I4 and (library or stor\$3)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2004/06/21 11:44
L7	65	macro\$4 and mask and I4 and (library or stor\$3) and (placement or position\$3)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR .	ON	2004/06/21 11:45